

**10/567889**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT: Marc REBAROT, et al.  
SERIAL NO.: unassigned  
FILING DATE: herewith  
TITLE: Method for Producing Inclined Flank Patterns by Photolithography  
EXAMINER: UNASSIGNED  
ART UNIT: UNASSIGNED

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COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria VA 22313-1450

**PRELIMINARY AMENDMENT**

Dear Sir:

Prior to examination, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 3  
of this paper.

**Remarks / Arguments** begin on page 6 of this paper.